



Docket No.: M4065.0466/P466
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Neal Rueger

Application No.: 09/938,644

Filed: August 27, 2001

For: METHOD AND APPARATUS FOR
MICROMACHINING USING A MAGNETIC
FIELD AND PLASMA ETCHING

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JUN 09 2003
GROUP 1700
Group Art Unit: 1165
Examiner: T. Mackey

REPLACEMENT AMENDMENT

Box Non-Fee Amendment
Commissioner for Patents
Washington, DC 20231

Dear Sir:

In response to the Office Action dated February 5, 2003 (Paper No. 4), and Notice dated May 7, 2003, please amend the above-identified U.S. patent application as follows:

In the Claims: amendments to the claims are as shown beginning at page 2.

Please consider the **Remarks**, which begin at page 11.